

Atty. Docket No. KIK01 P-322

#14C  
Amend  
S Davis  
8/15/03

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit : 2863  
Examiner : Xiuqin Sun ✓  
Appln. No. : 09/838,905 ✓  
Applicant : Kenichiro Kobayashi  
Filing Date : April 20, 2001 ✓  
Confirmation No. : 1673  
For : METHOD AND APPARATUS TO MEASURE AMOUNT OF  
MOVEMENT USING GRANULAR SPECK PATTERN  
GENERATED BY REFLECTING LASER BEAM

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

AMENDMENT AFTER APPEAL UNDER 37 C.F.R. §1.116

Amendments to the claims are reflected in the listing of claims which begins on page  
2 of this paper.

Remarks begin on page 6 of this paper.

FAX RECEIVED

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